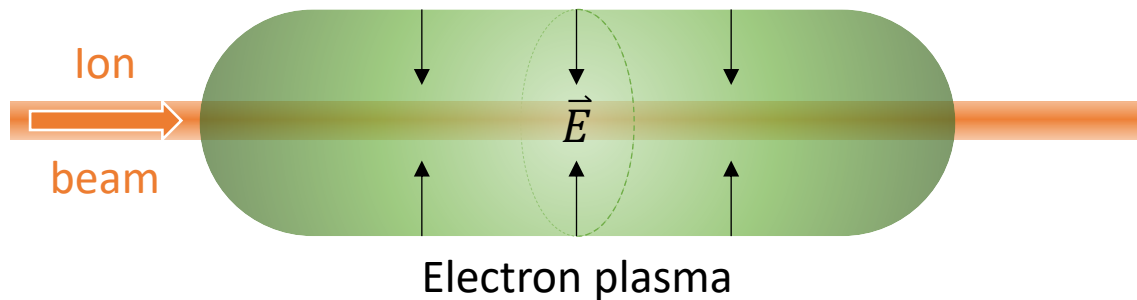


Proton and Ion Capture

Gabor Lens

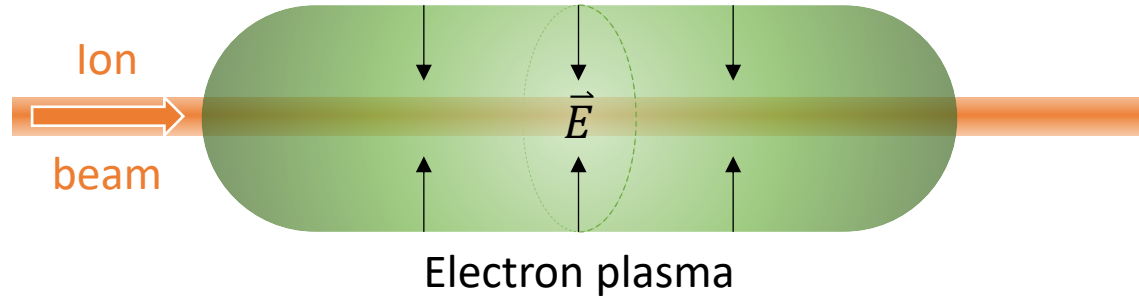


- The focal length (f) of the Gabor lens:

$$\frac{1}{f} = \frac{e^2 n_e l}{4\epsilon_0 U}$$

- where e is electric charge of the electron
 n_e is the plasma density
 l is the length of the plasma
 ϵ_0 is the permittivity of free space
 U is the kinetic energy of the positively charge particle.

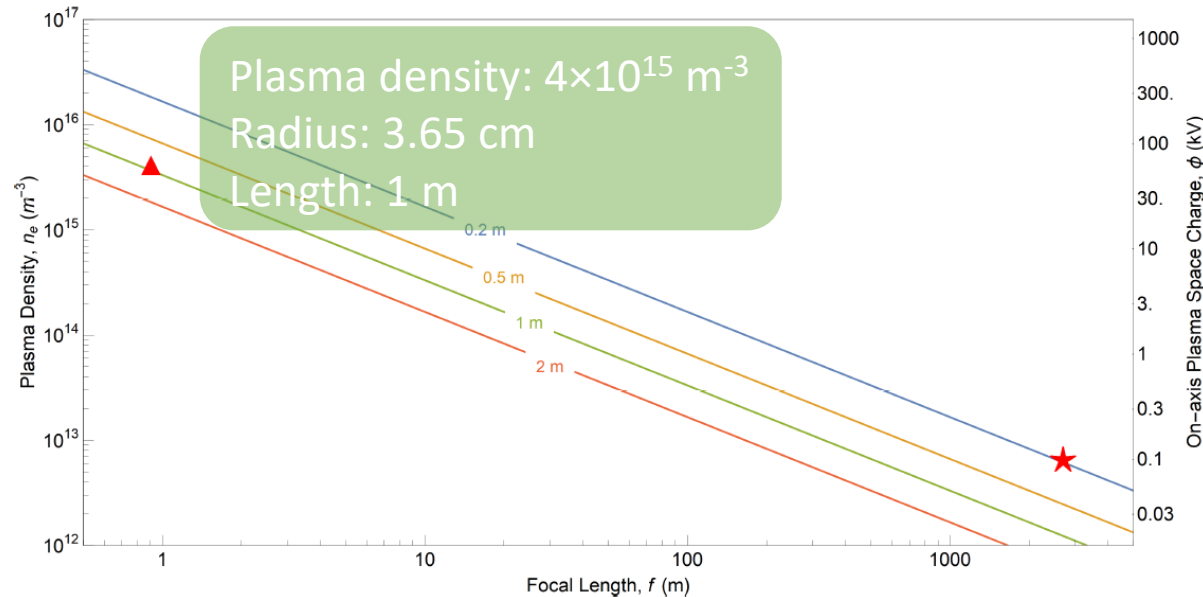
Gabor Lens



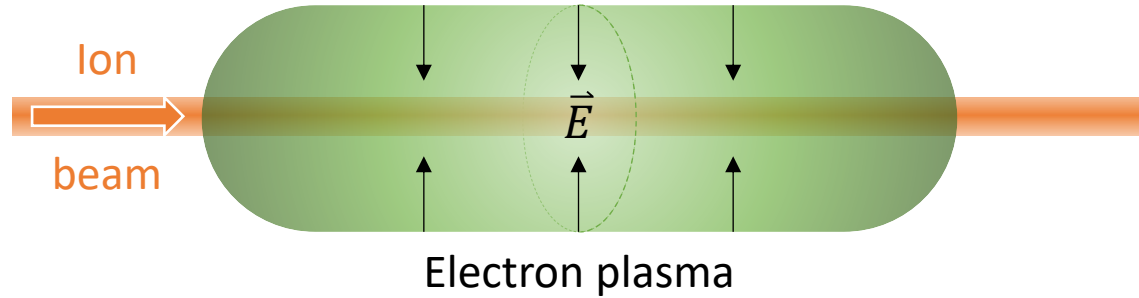
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Gabor Lens

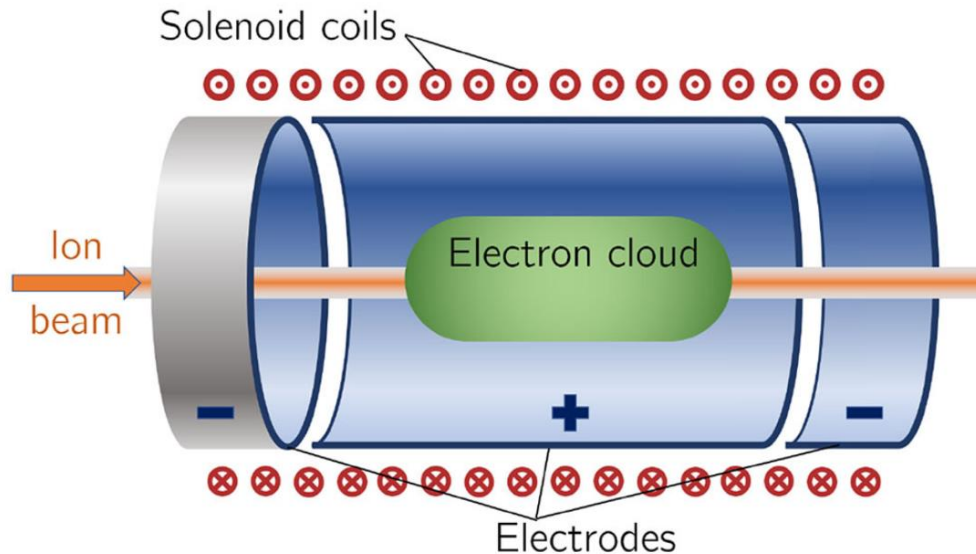


- The focal length (f) of the Gabor lens:

$$\frac{1}{f} = \frac{e^2 n_e l}{4\epsilon_0 U}$$

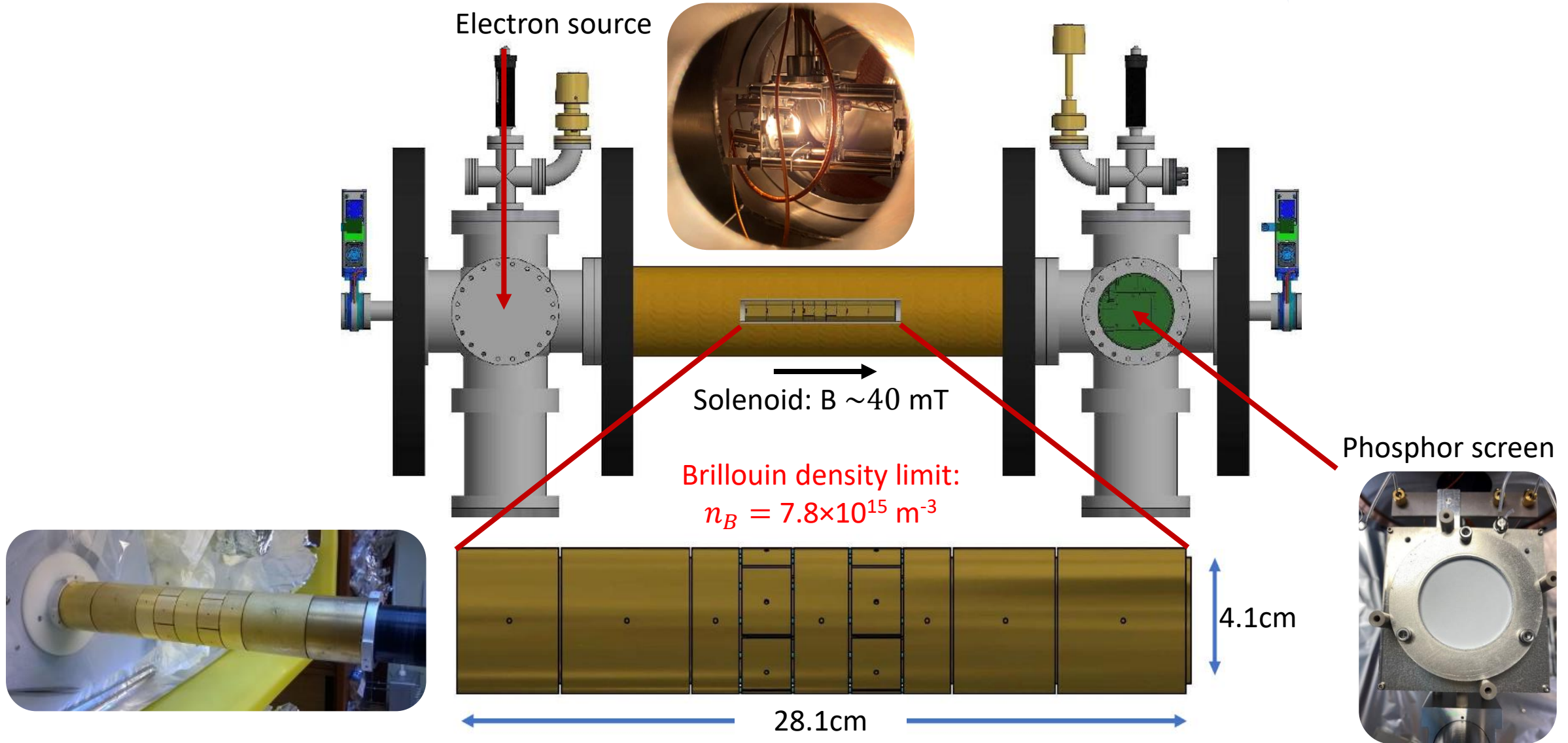
- where e is electric charge of the electron
 n_e is the plasma density
 l is the length of the plasma
 ϵ_0 is the permittivity of free space
 U is the kinetic energy of the positively charge particle.

- Penning-Malmberg Trap



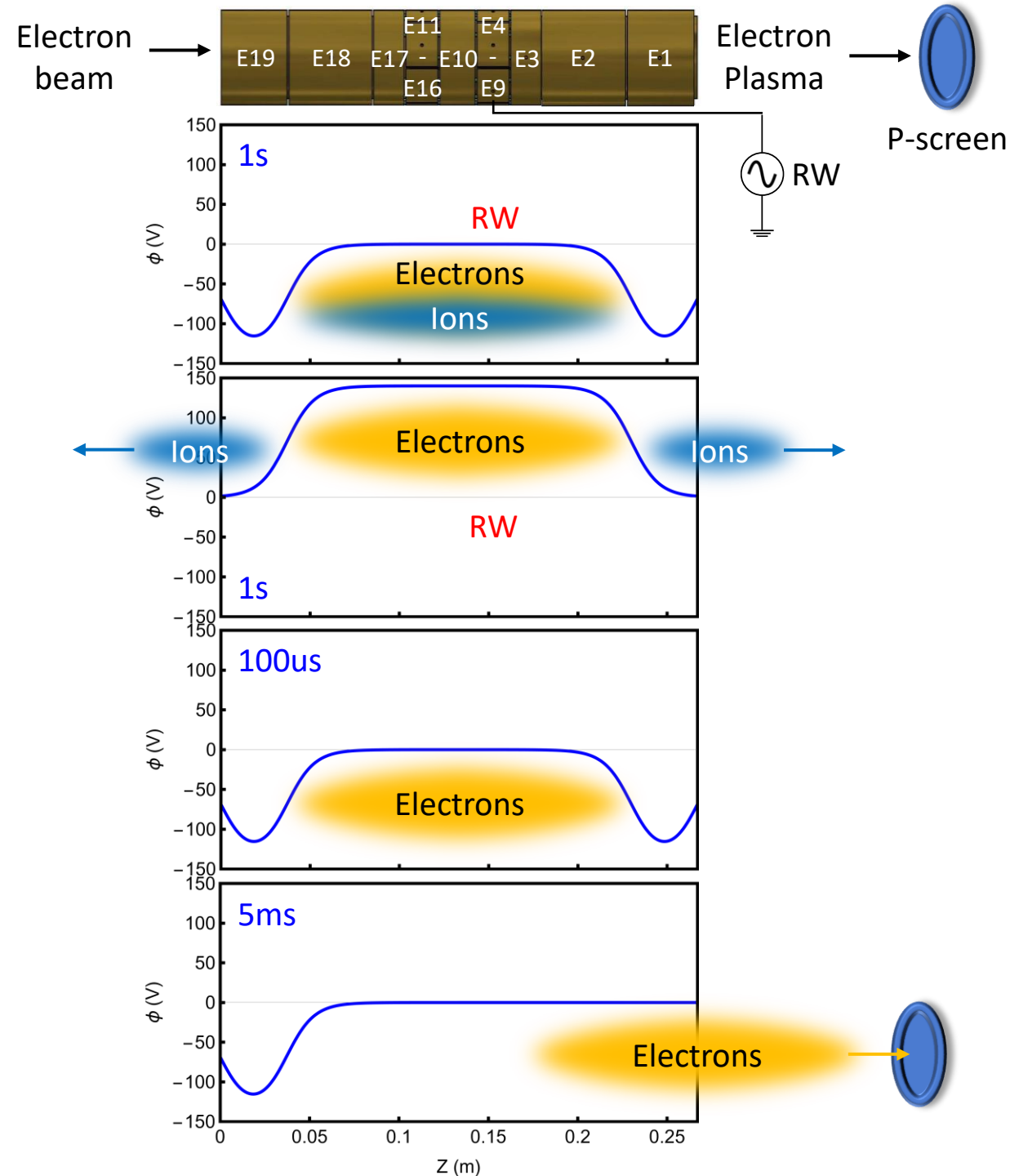
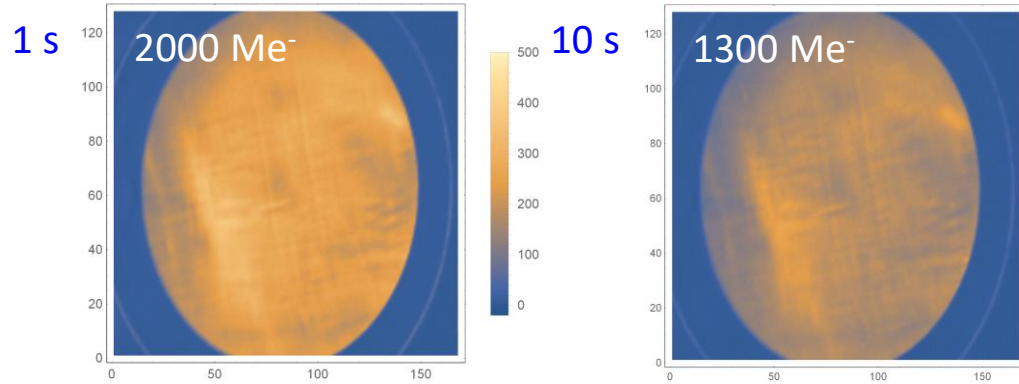
Aymar, G., Becker, T., Boogert, S., Borghesi, M., Bingham, R., Brenner, C., ... & Xiao, R. (2020). LhARA: the laser-hybrid accelerator for radiobiological applications. *Frontiers in Physics*, 8, 567738.

Experimental Setup



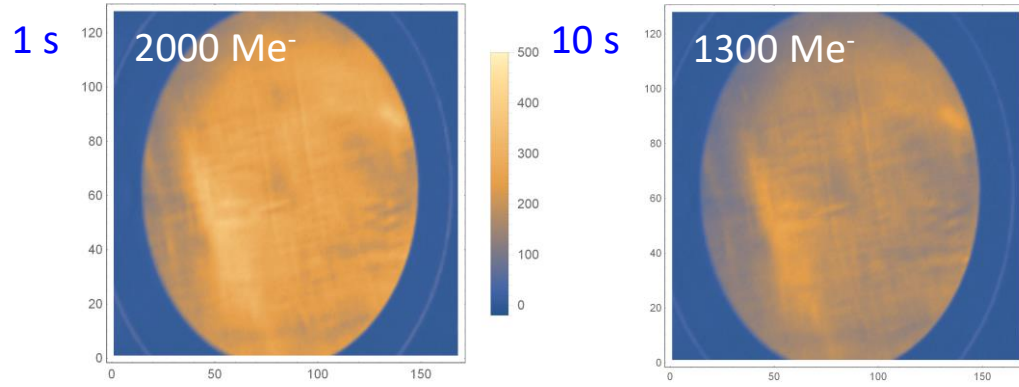
Previous Results

- 140 voltage trap, Rotating wall (RW) + Cooling gas (CO_2)

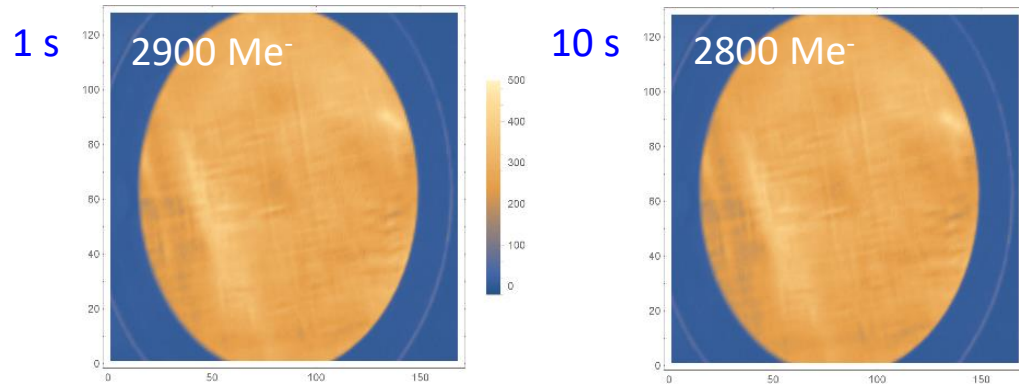


Previous Results

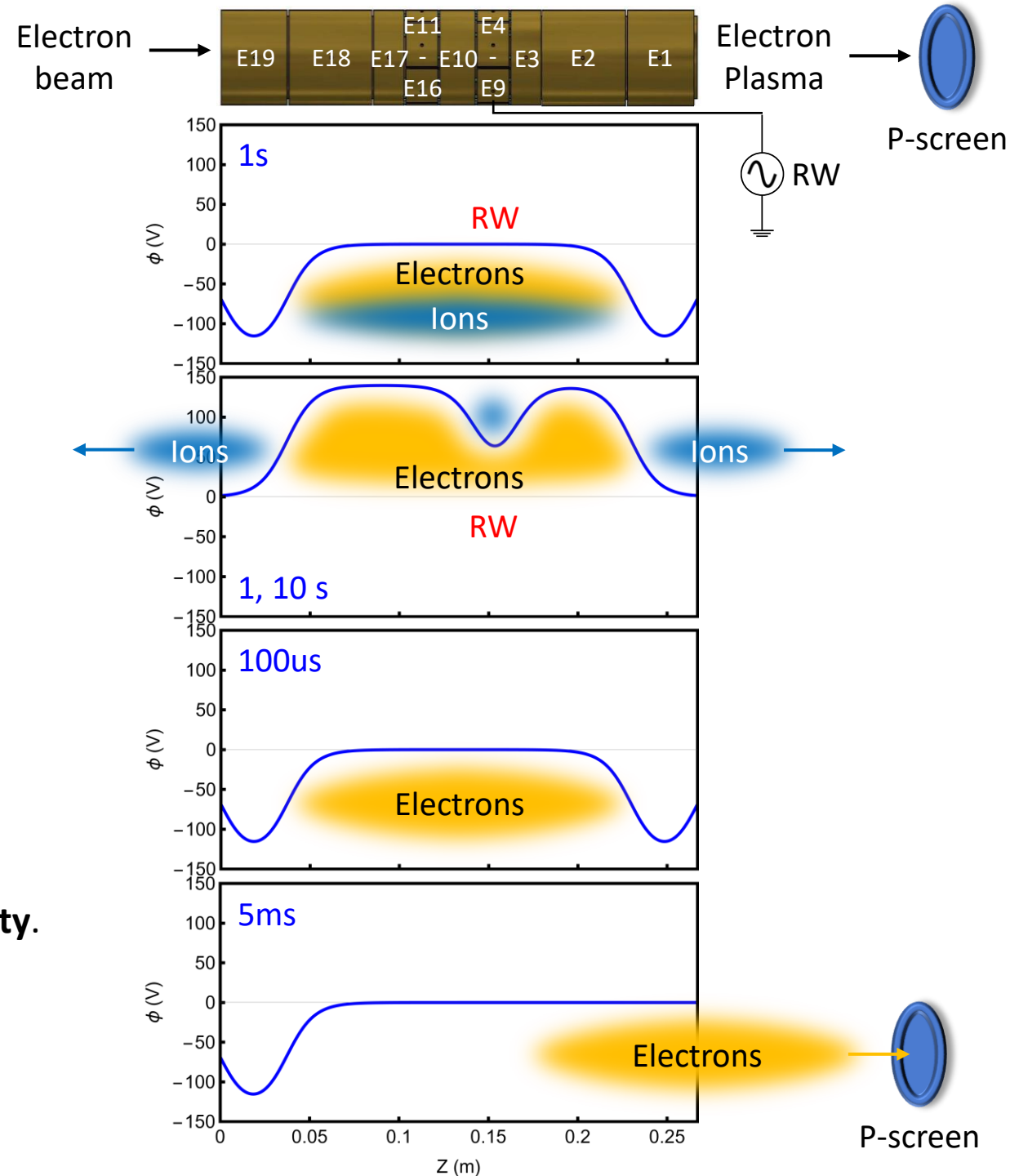
- 140 voltage trap, Rotating wall (RW) + Cooling gas (CO_2)



With dimple



- The plasma has a high electron number and exhibits **high density**.
- The plasma remains **stable** as long as the RW is applied.



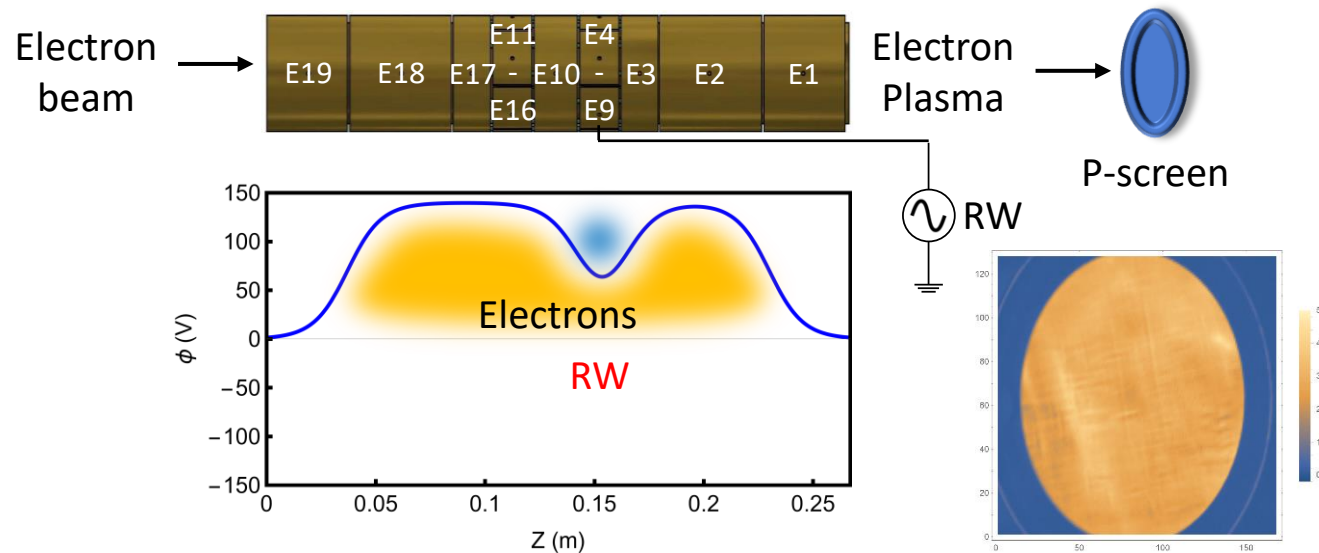
Results

1. Investigate the mechanism responsible for the creation of this high-density, stable plasma.
2. Investigate the required initial electron number for high density plasma formation.
3. Examine the plasma mode.

Results

1. Investigate the mechanism responsible for the creation of this high-density, stable plasma.

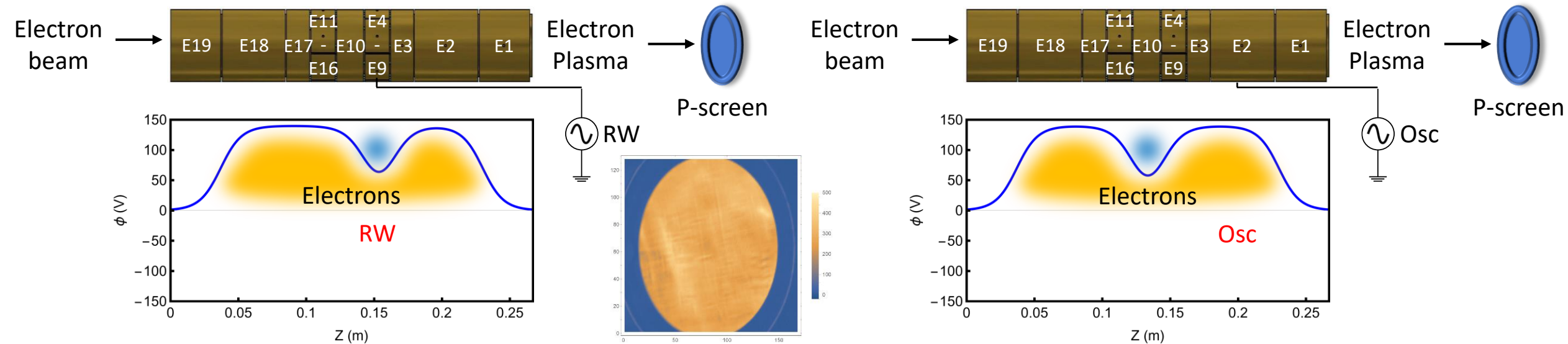
Key features	Mechanism
1. High electron number and high density	Ionization between the RF heating (from RW) and the background gas (CO_2)
2. Stable	Dimple that confines trapped ions



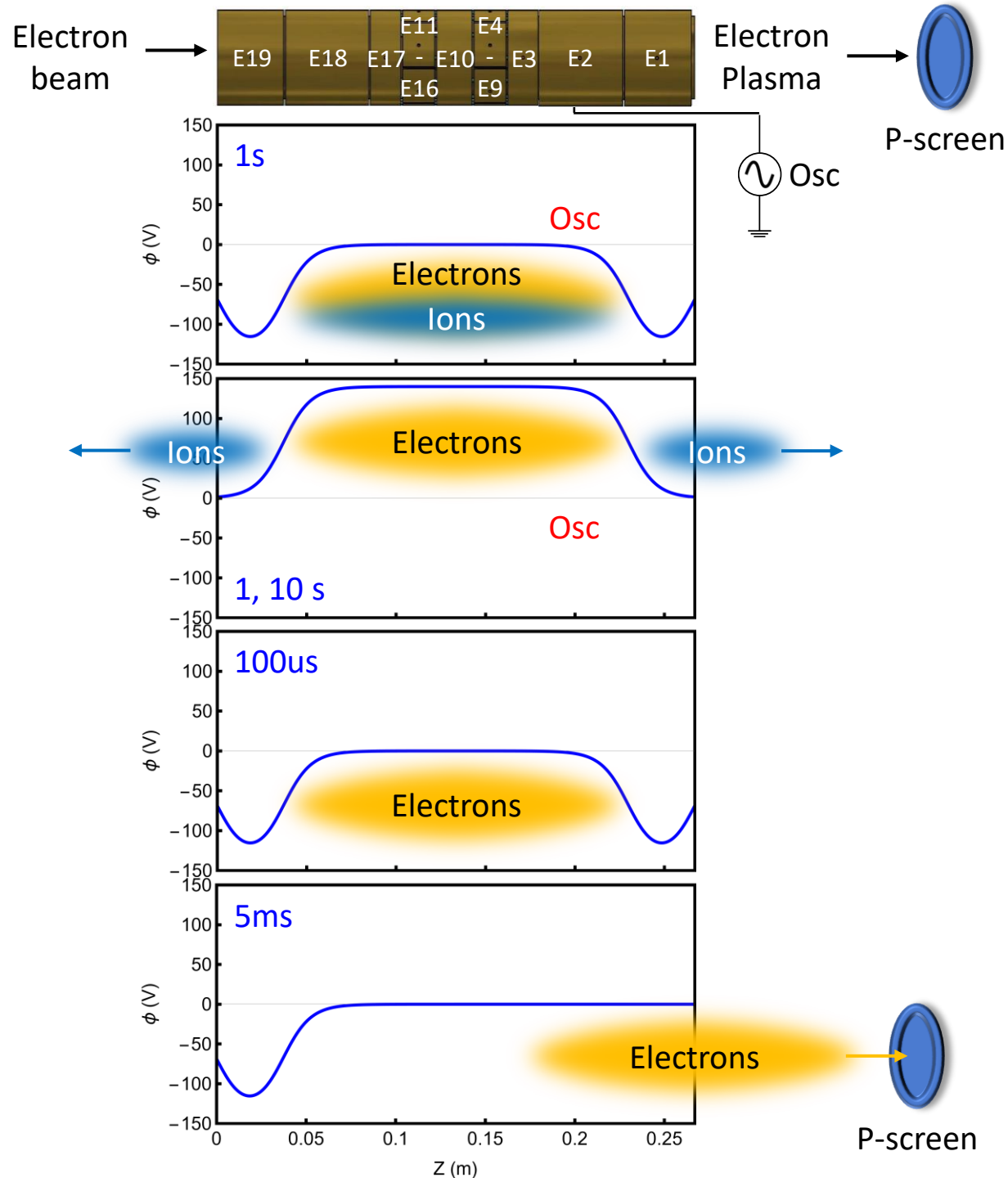
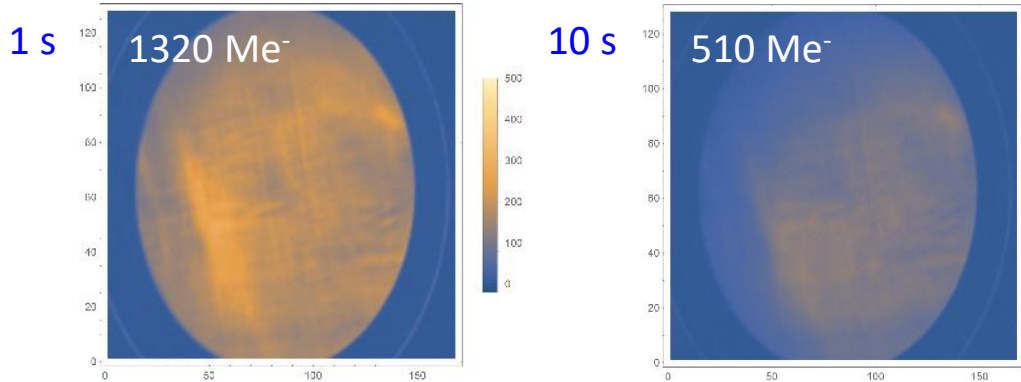
Results

1. Investigate the mechanism responsible for the creation of this high-density, stable plasma.

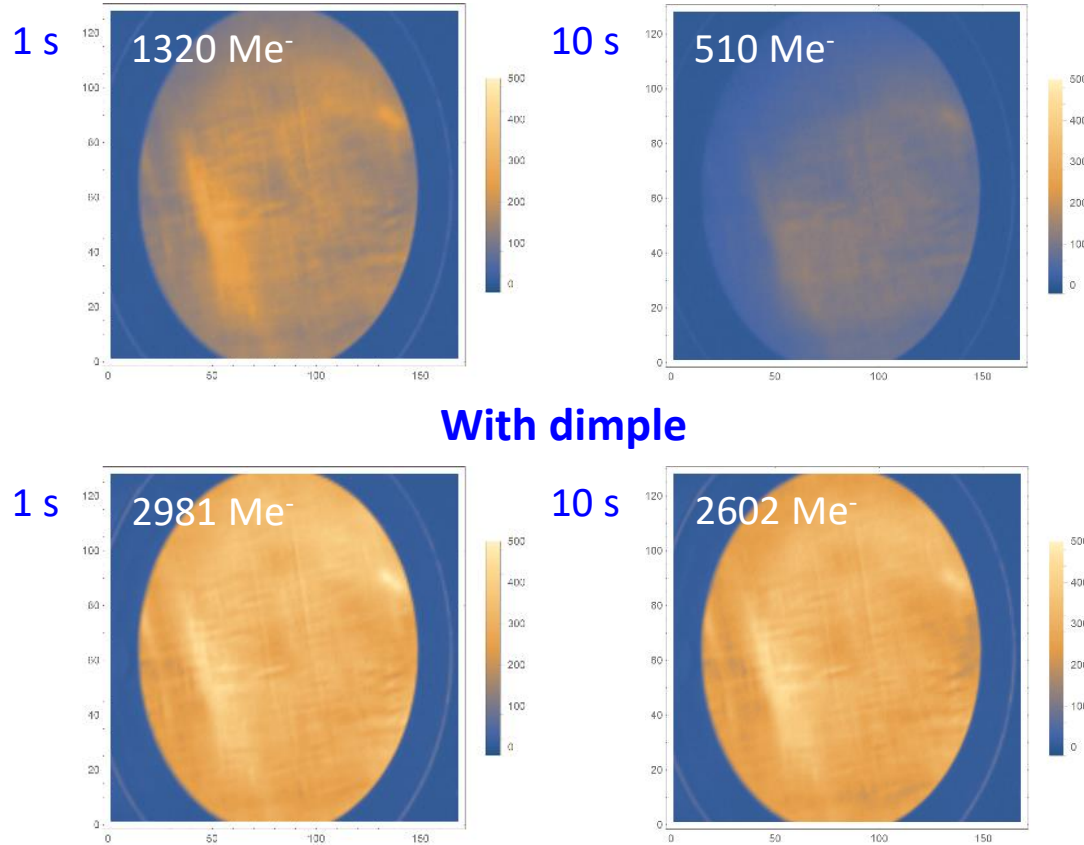
Key features	Mechanism	Experiment simplification
1. High electron number and high density	Ionization between the RF heating (from RW) and the background gas (CO_2)	Apply an oscillating field to E2
2. Stable	Dimple that confines trapped ions	Create a dimple on E10



Apply Oscillating field

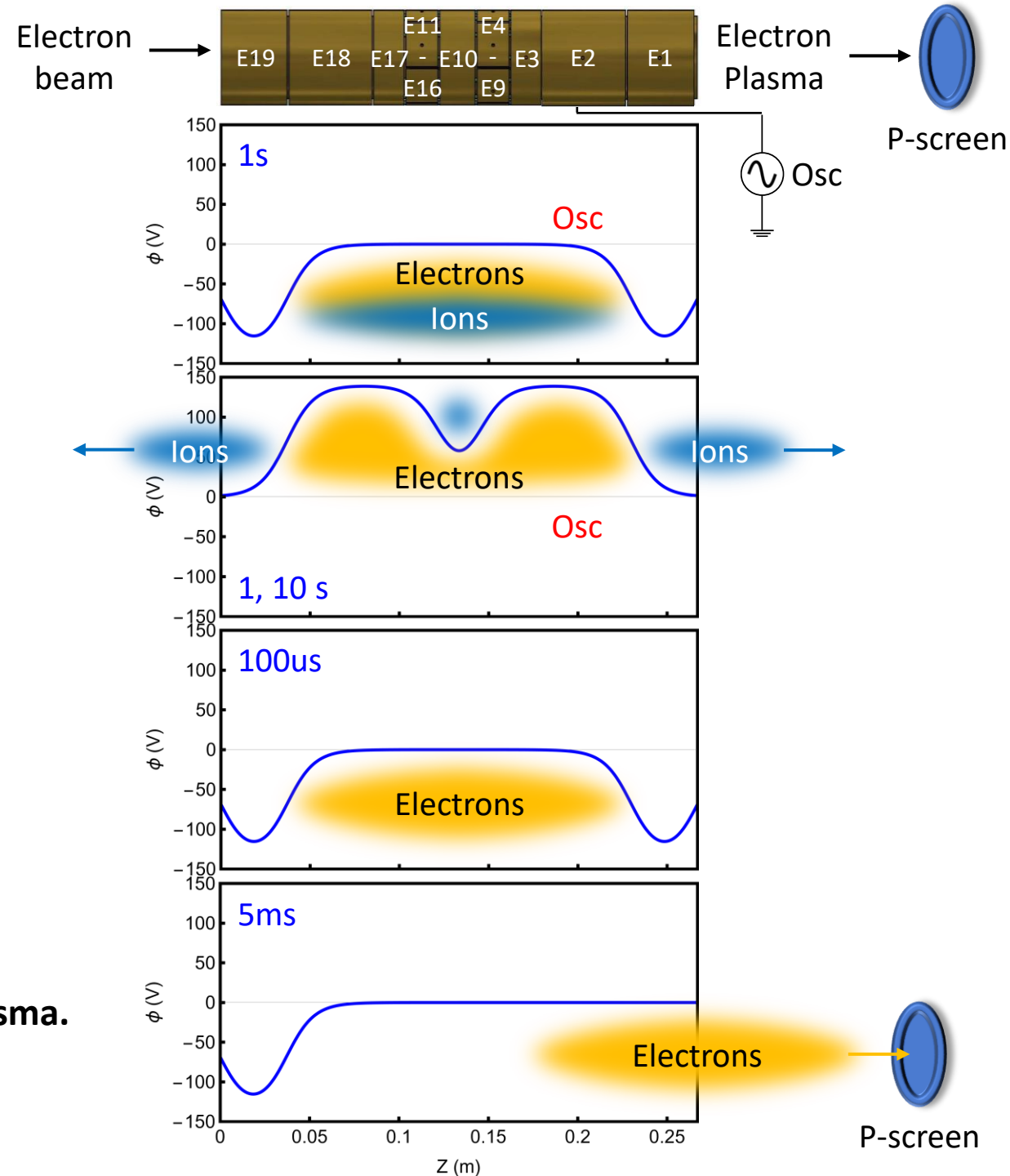


Apply Osc + Dimple

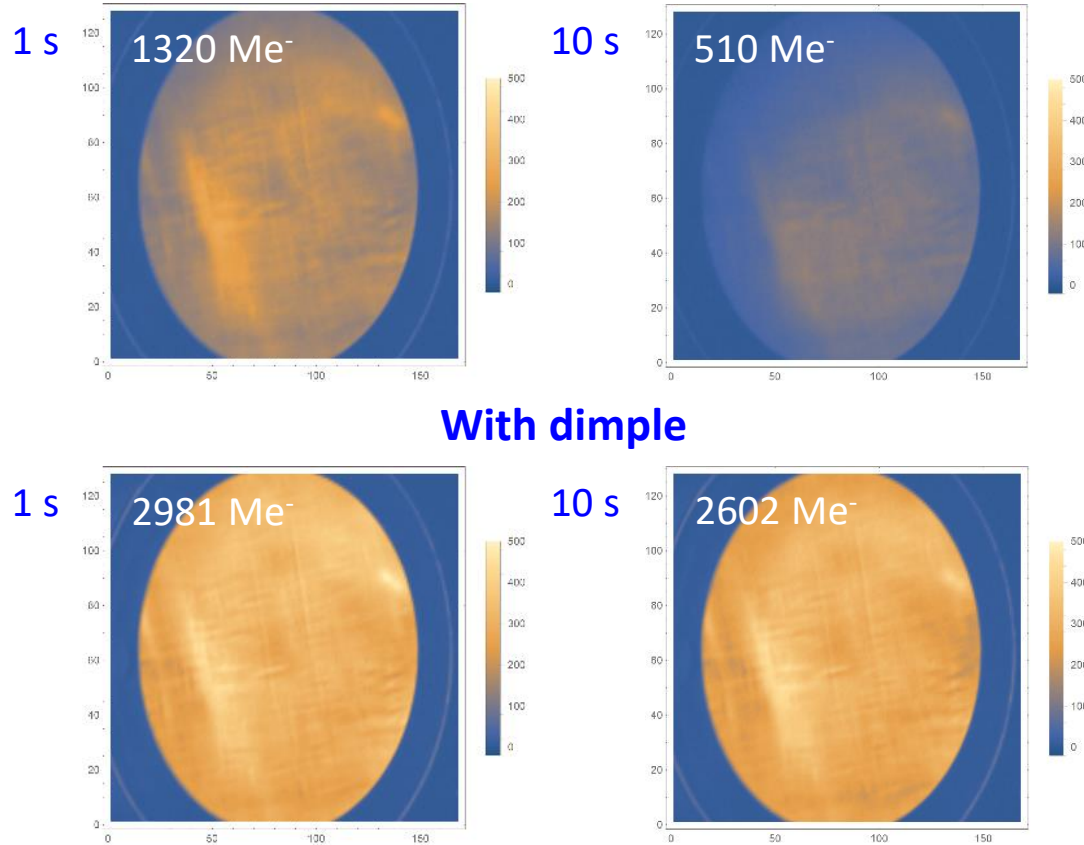


Discussions:

- The oscillating field alone can generate a plasma; however, the resulting electron density is low, and the plasma lacks stability.
- The dimple is essential for producing a stable, high-density plasma.**



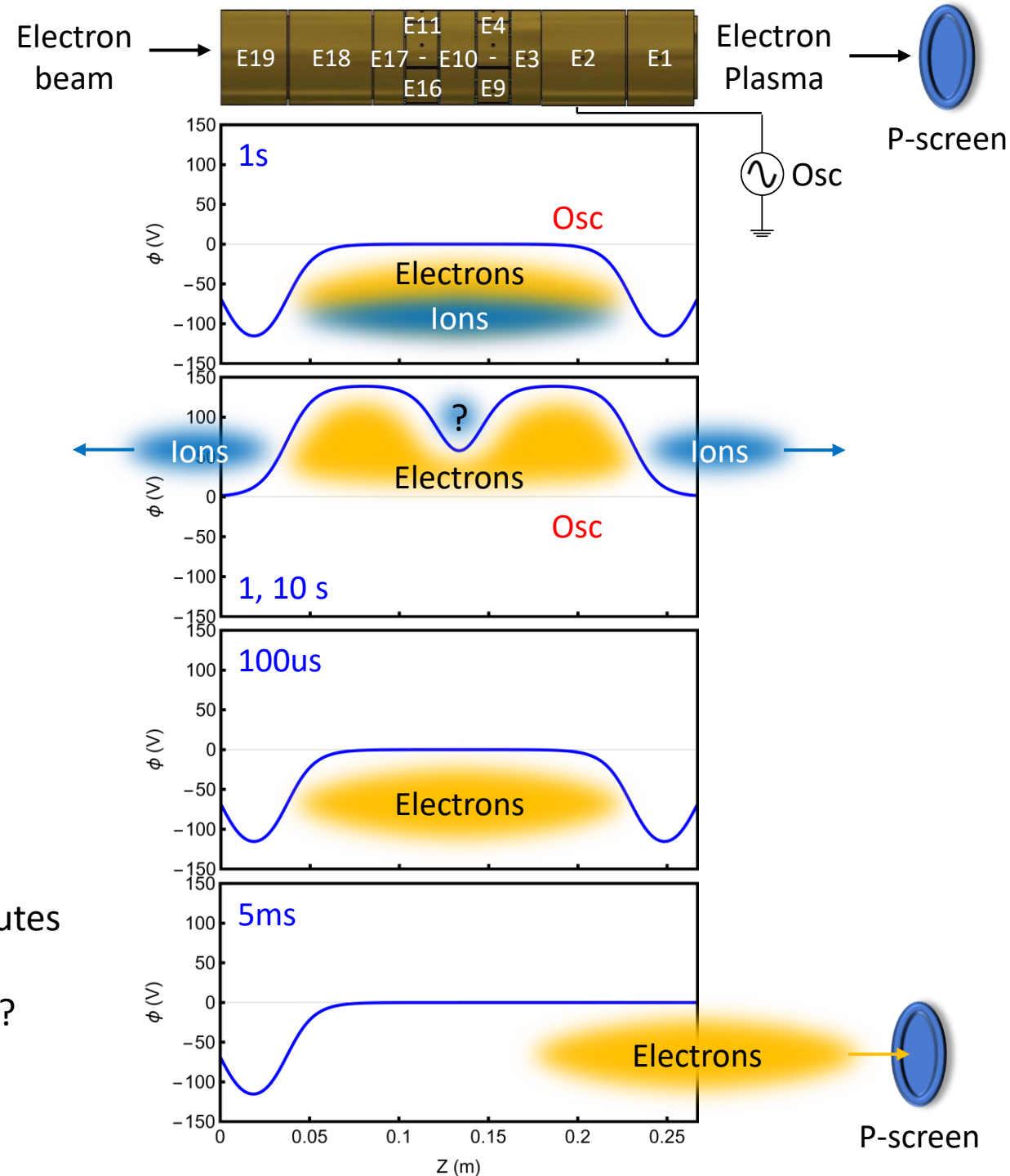
Apply Osc + Dimple



With dimple

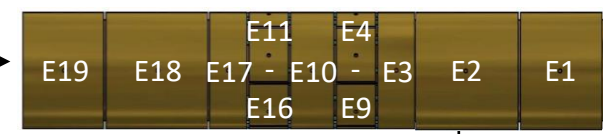
Question:

- What is the underlying mechanism by which the dimple contributes to the stability and high-density of the plasma? Is it due to the dimple or the trapped ions or both the dimple and trapped ions?

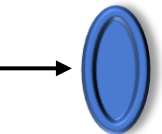


Ion detection

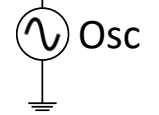
Electron beam



Electron Plasma



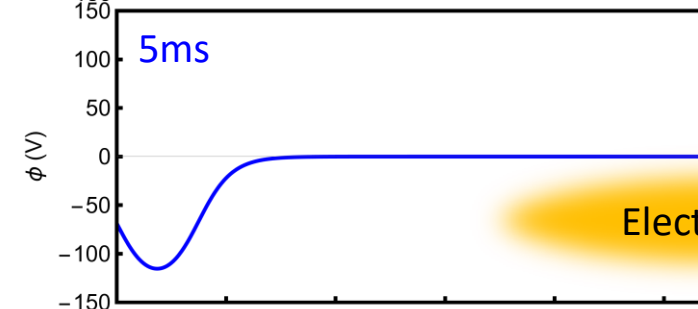
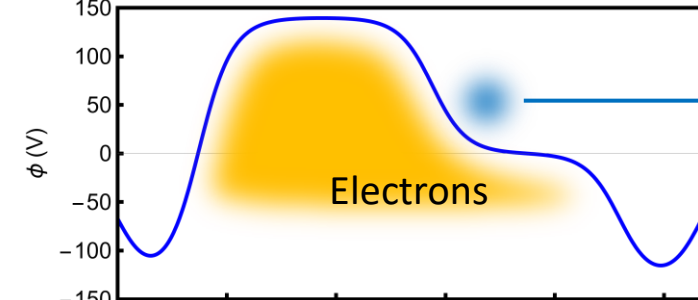
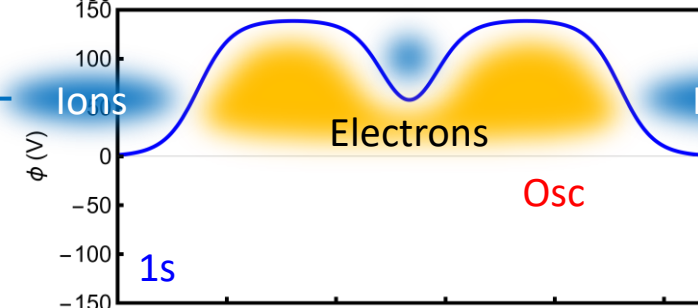
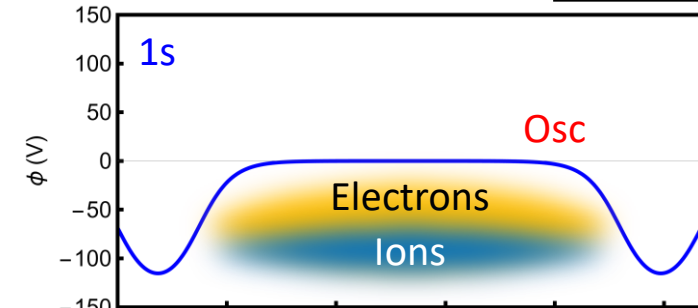
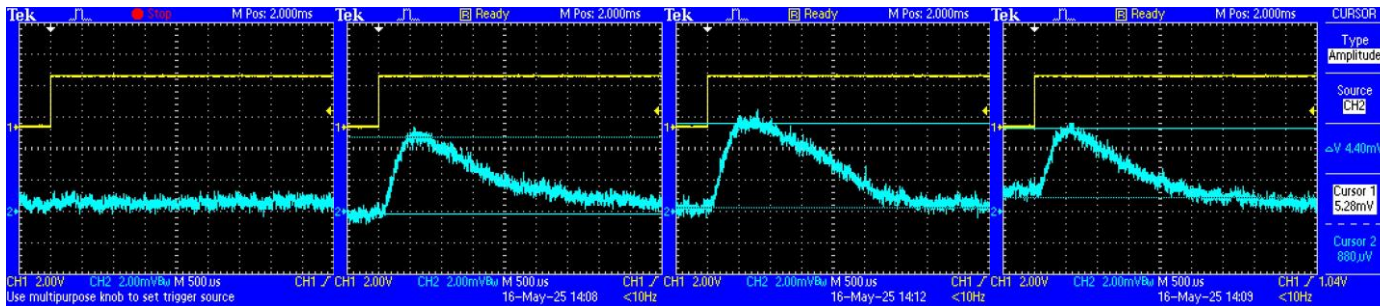
P-screen



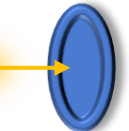
Voltage amplitude: 4.88 mV (29.2 M ions)

Background signal
(Turn off Osc field)

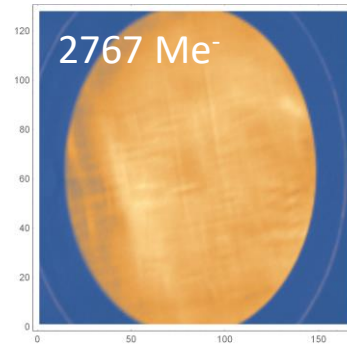
Ion signals
(Osc field applied)



P-screen

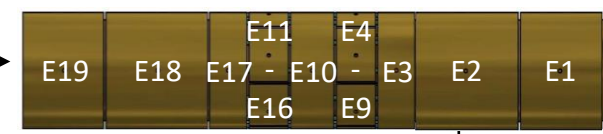


P-screen

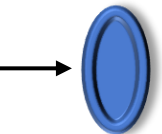


Ion detection

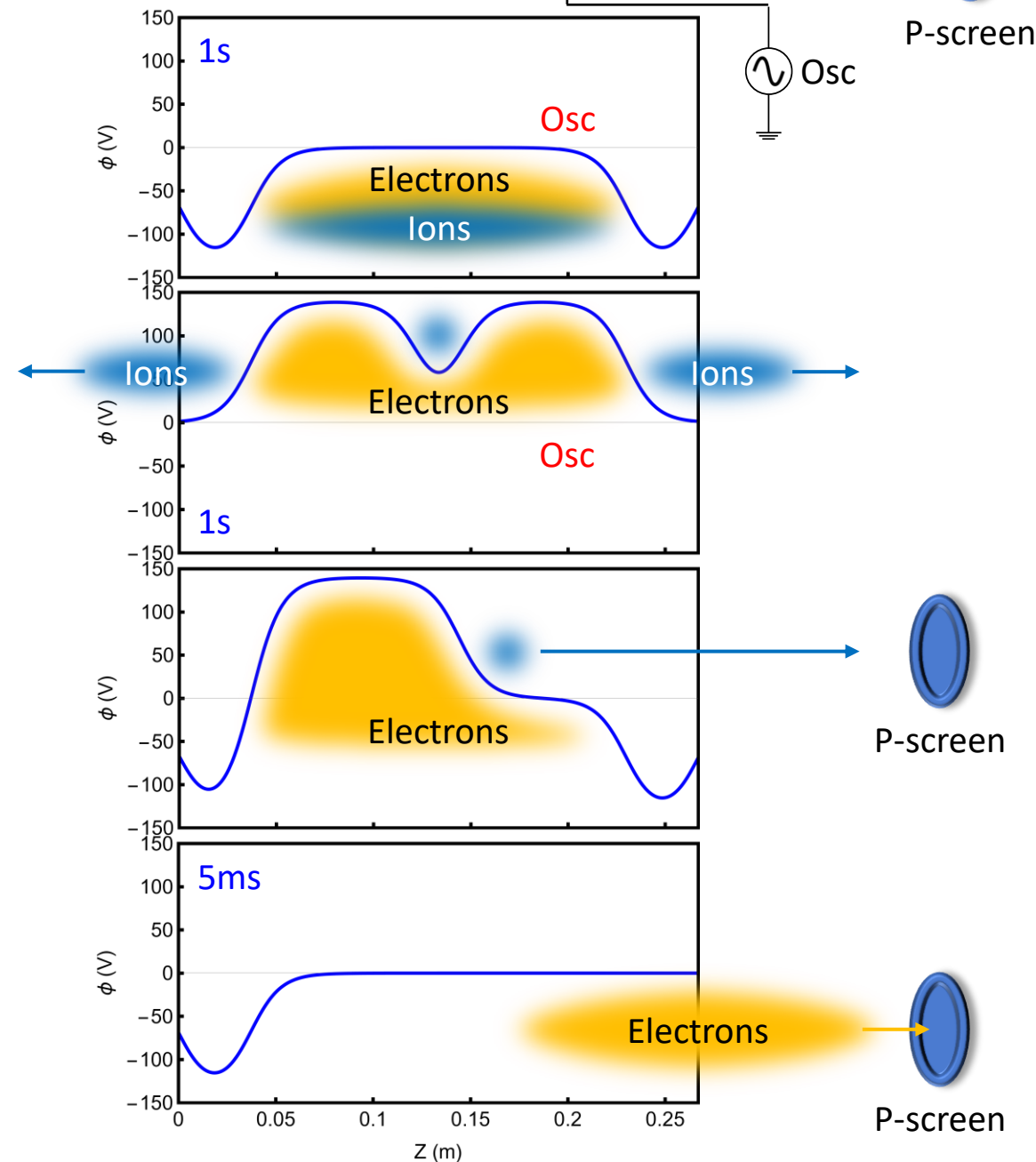
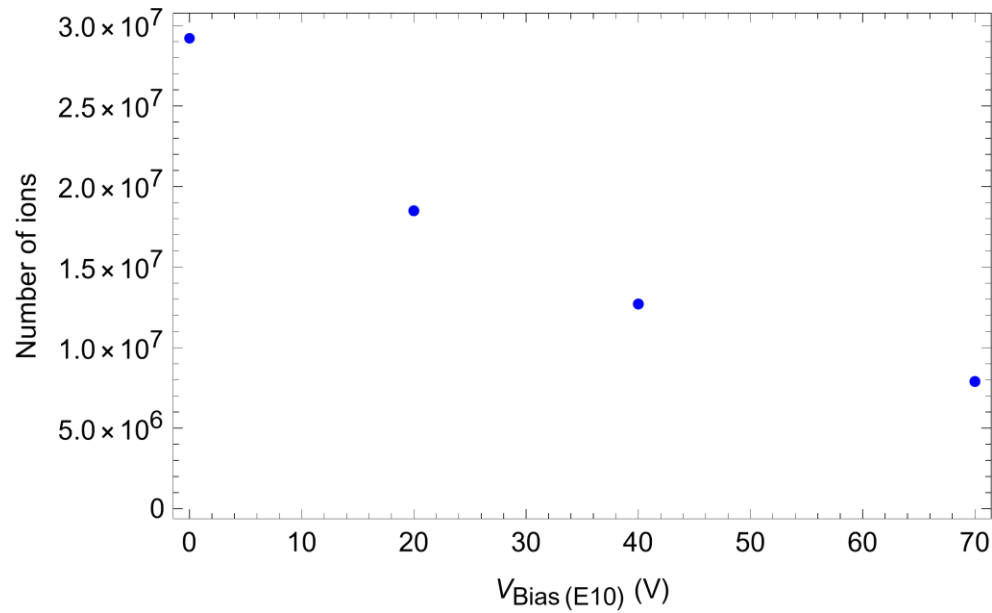
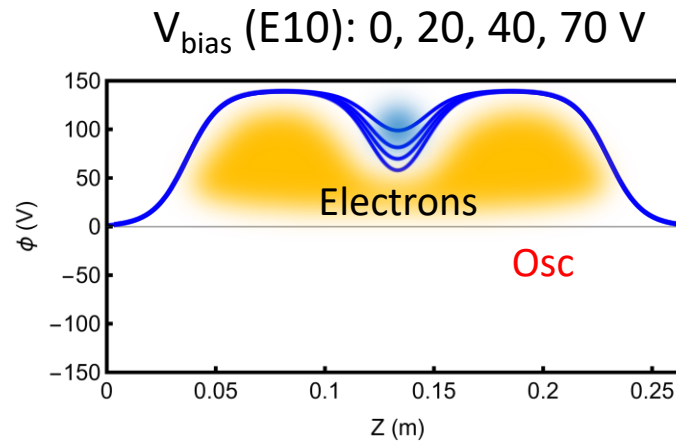
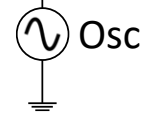
Electron
beam



Electron
Plasma



P-screen



Conclusions

1. Investigate the mechanism responsible for the creation of this high-density, stable plasma.

To generate a stable and high-density plasma, two key components are required:

1. Oscillating electric field
2. Dimple that traps ions

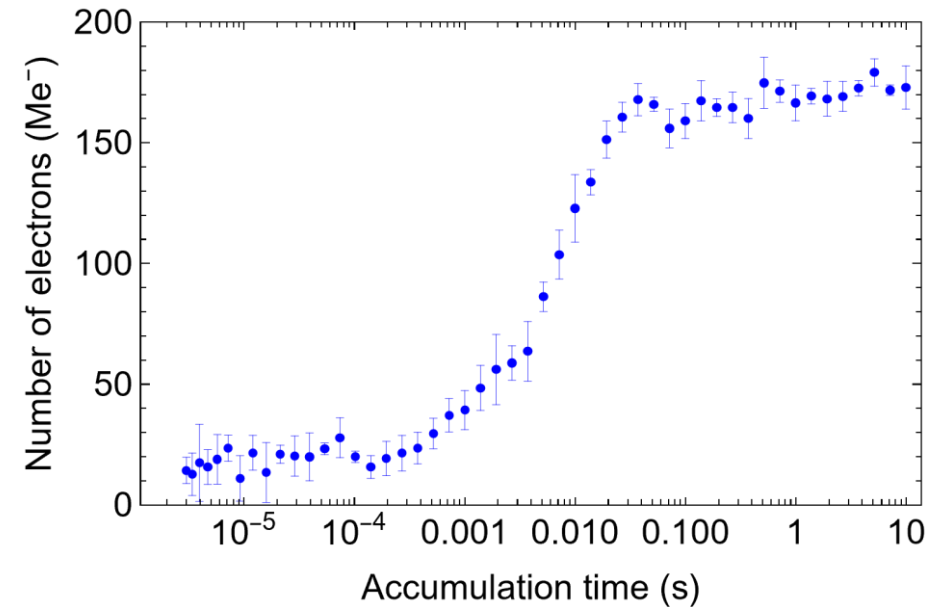
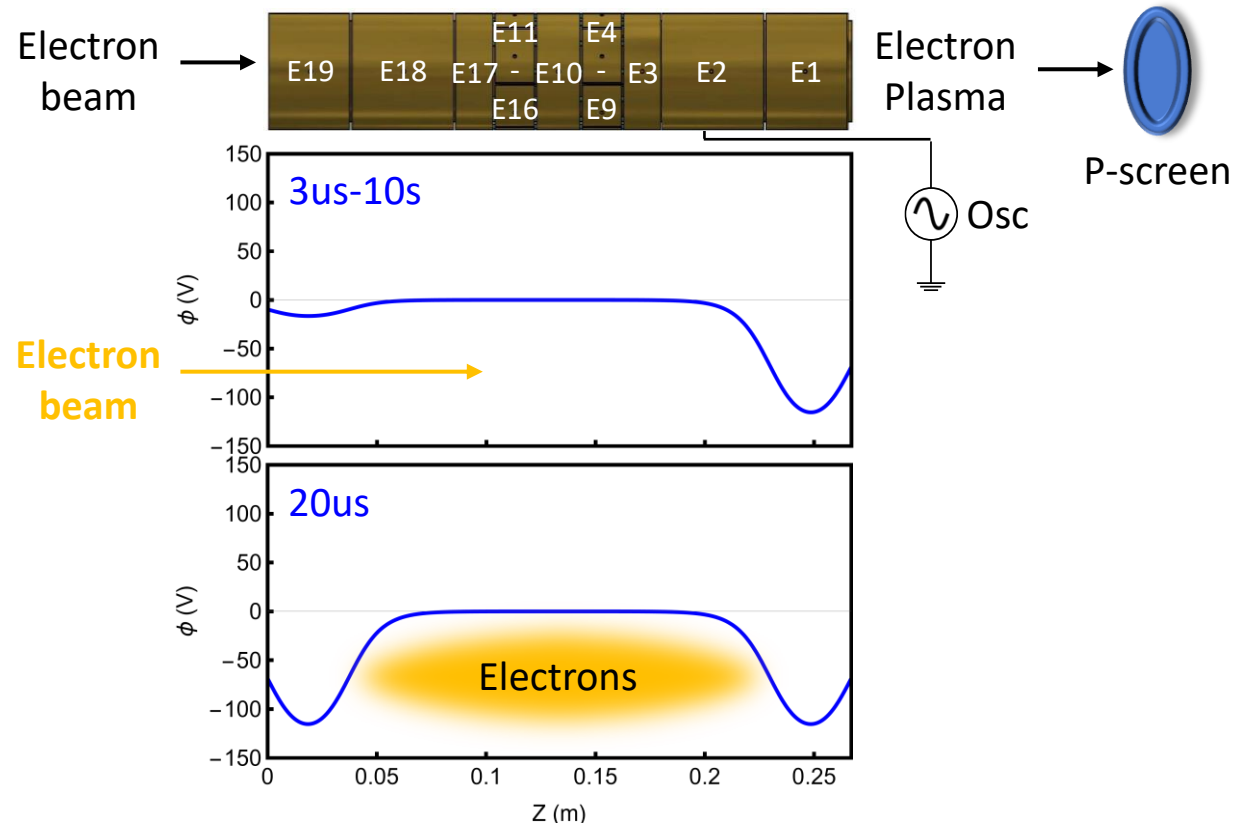
Results

1. Investigate the mechanism responsible for the creation of this high-density, stable plasma.
2. Investigate the required initial electron number for high density plasma formation.
3. Examine the plasma mode.

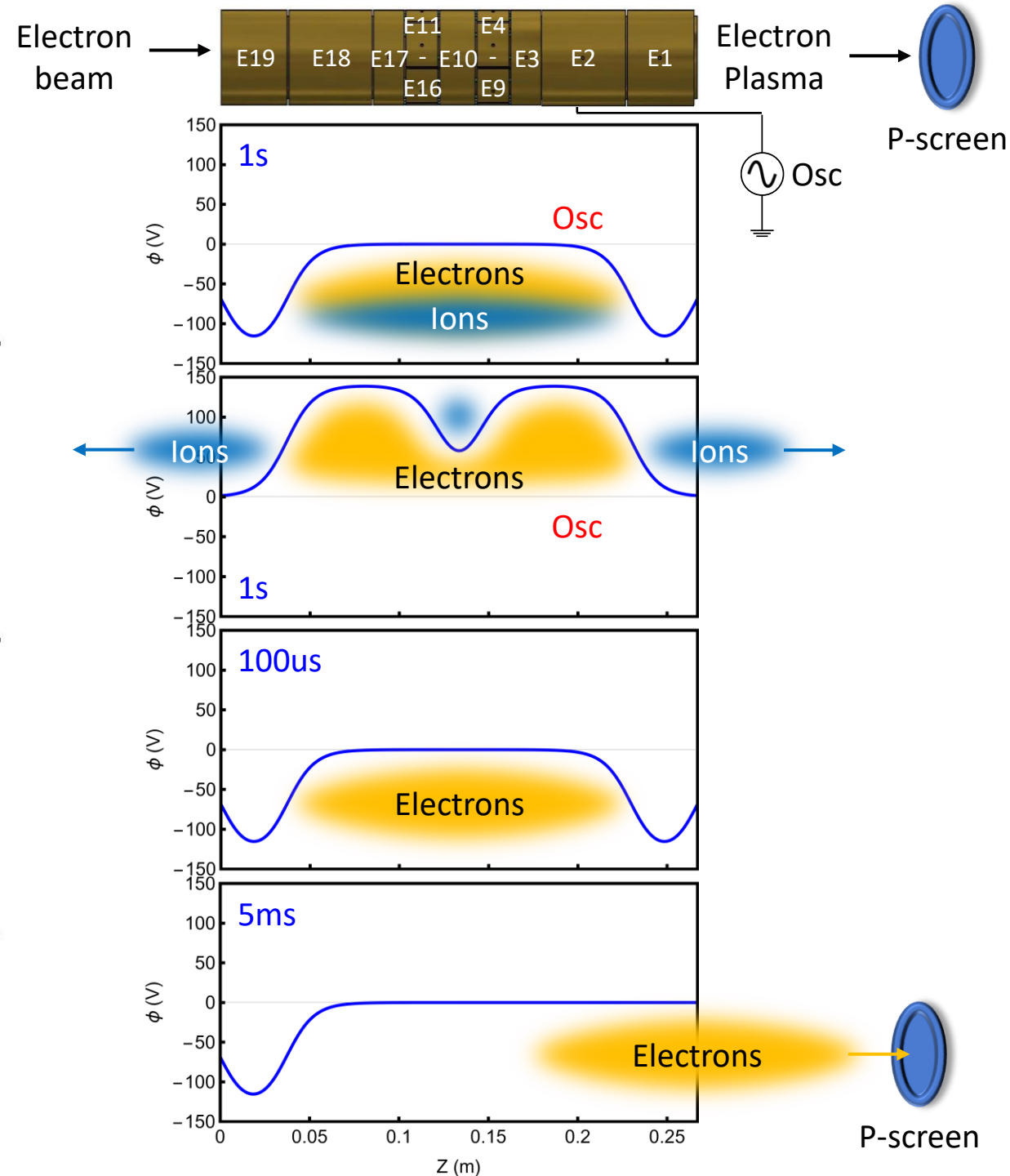
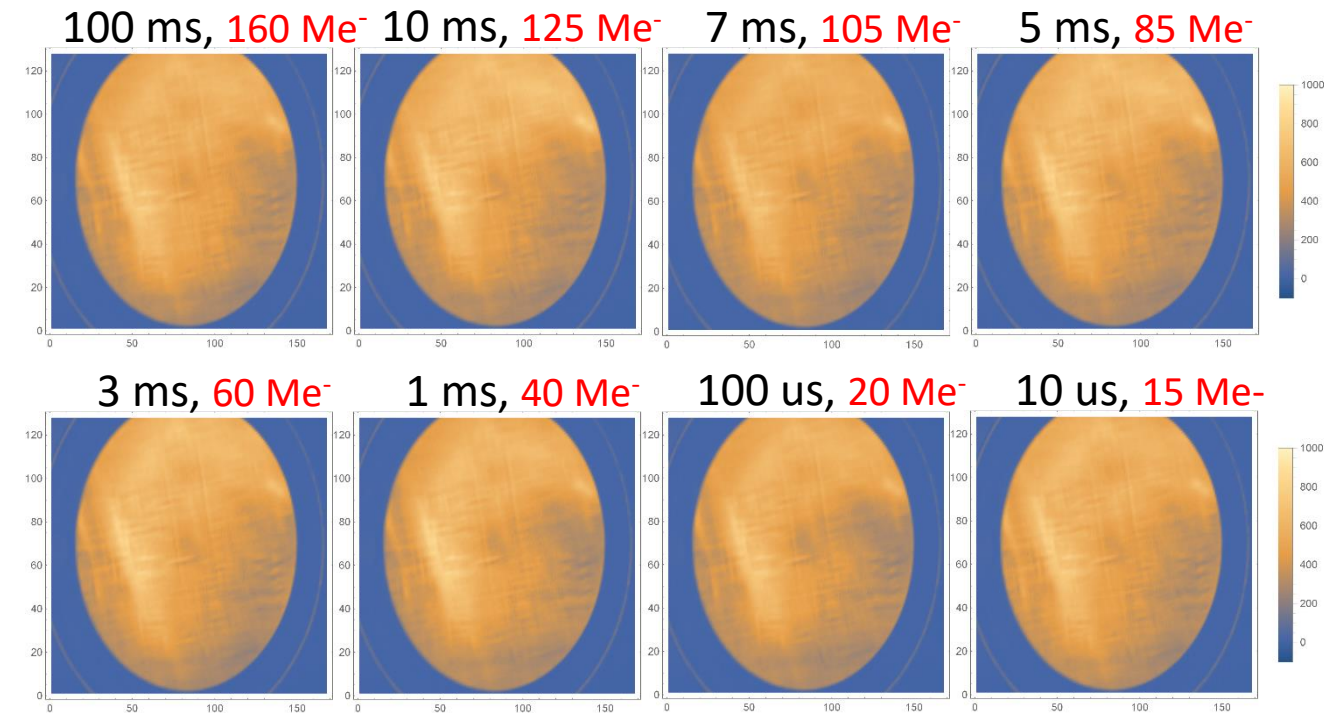
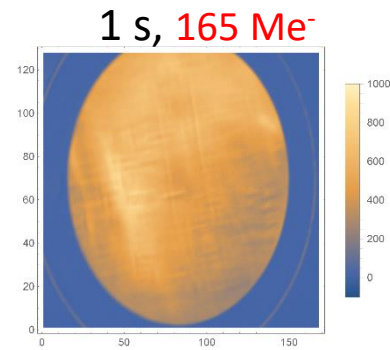
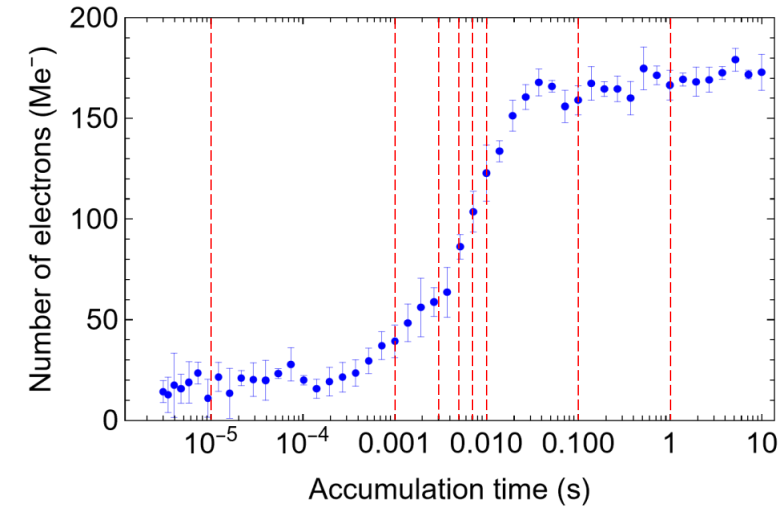
Results

2. Investigate the required initial electron number for high density plasma formation.

Vary the initial electron number by adjusting the accumulation time.



Vary initial e^- number



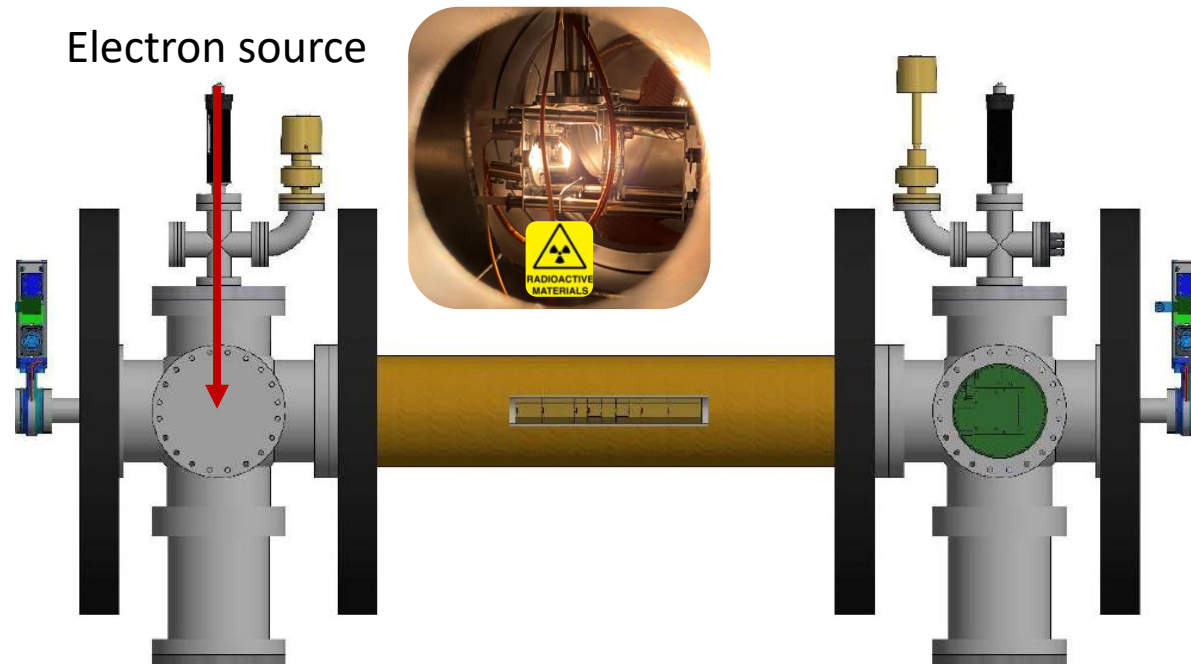
Conclusions

2. Investigate the required initial electron number for high density plasma formation.

To generate a stable and high-density plasma, two key components are required:

1. Oscillating electric field
2. Dimple that traps ions

Notably, this plasma can be initiated using a very small number of seed electrons.



Results

1. Investigate the mechanism responsible for the creation of this high-density, stable plasma.
2. Investigate the required initial electron number for high density plasma formation.
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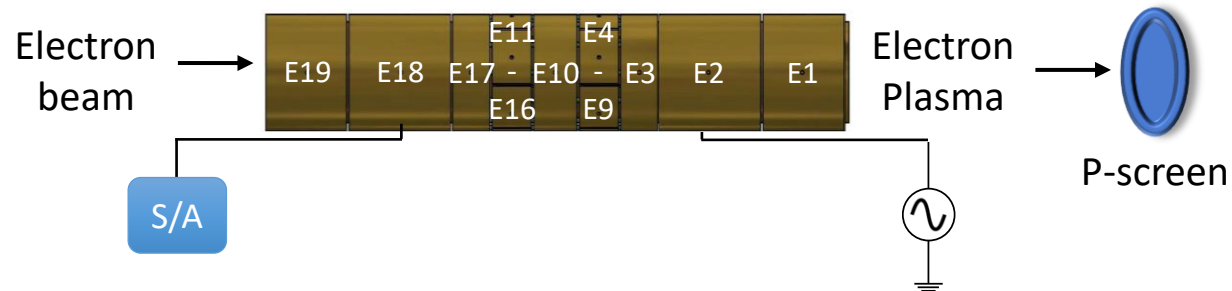
Results

3. Examine the plasma mode.

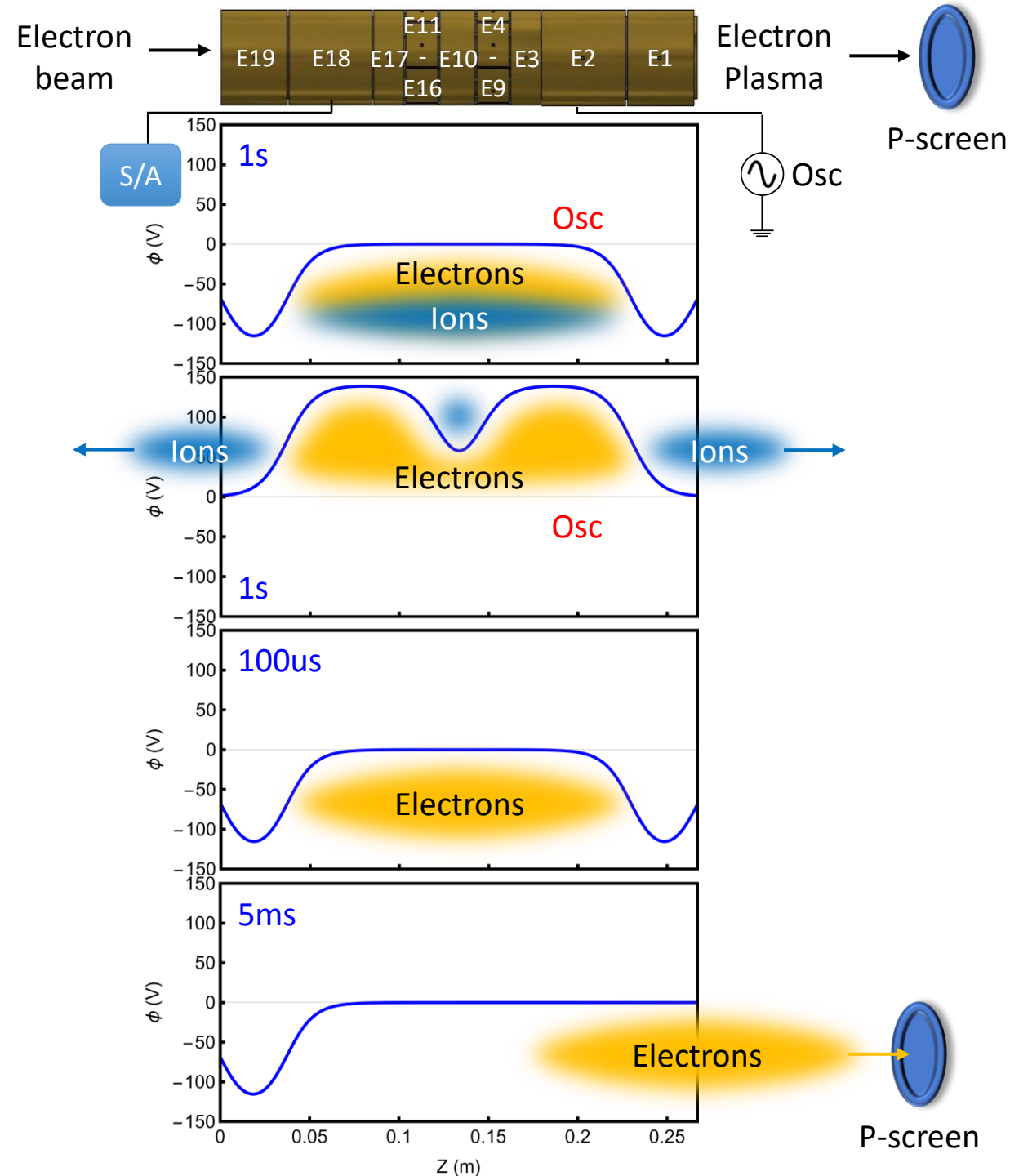
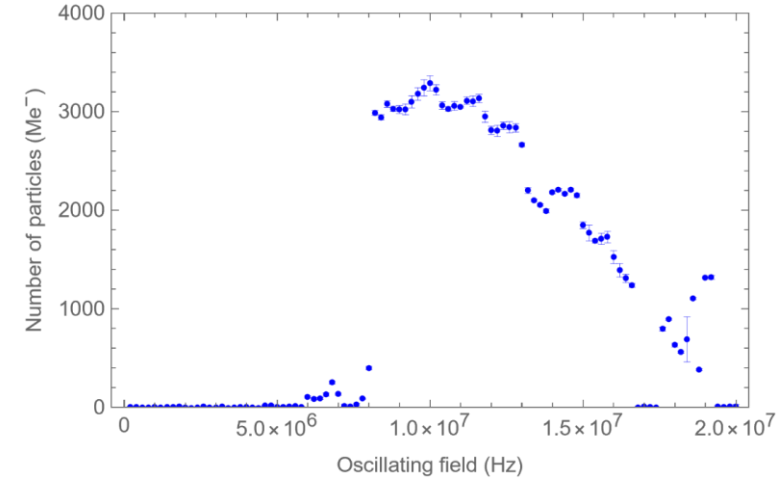
Plasma mode refers to the collective oscillations or wave-like behaviour exhibited by a plasma. Studying plasma modes is important because they provide valuable insights into:

Plasma properties such as density, temperature, and particle number.

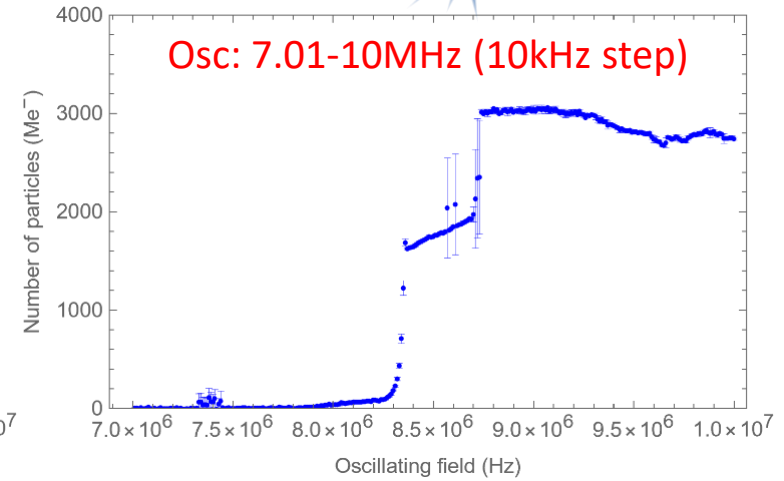
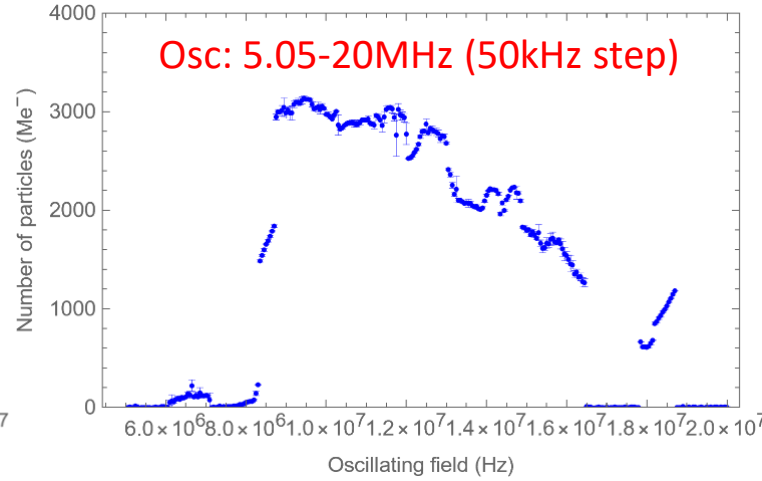
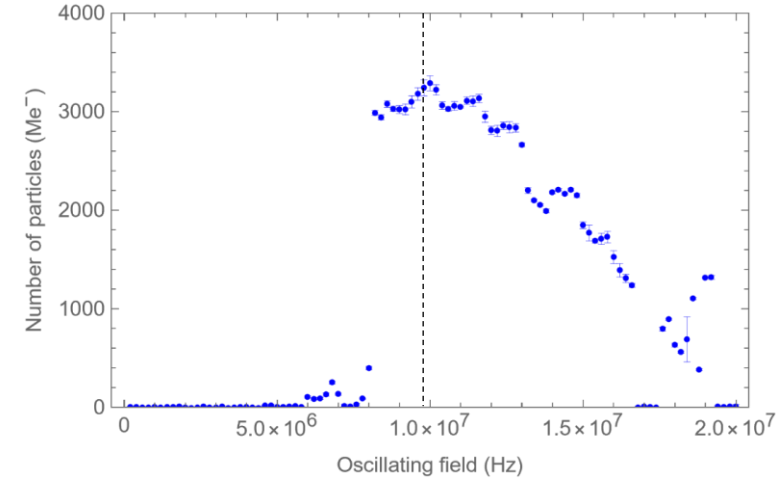
Plasma stability and confinement within the trap.



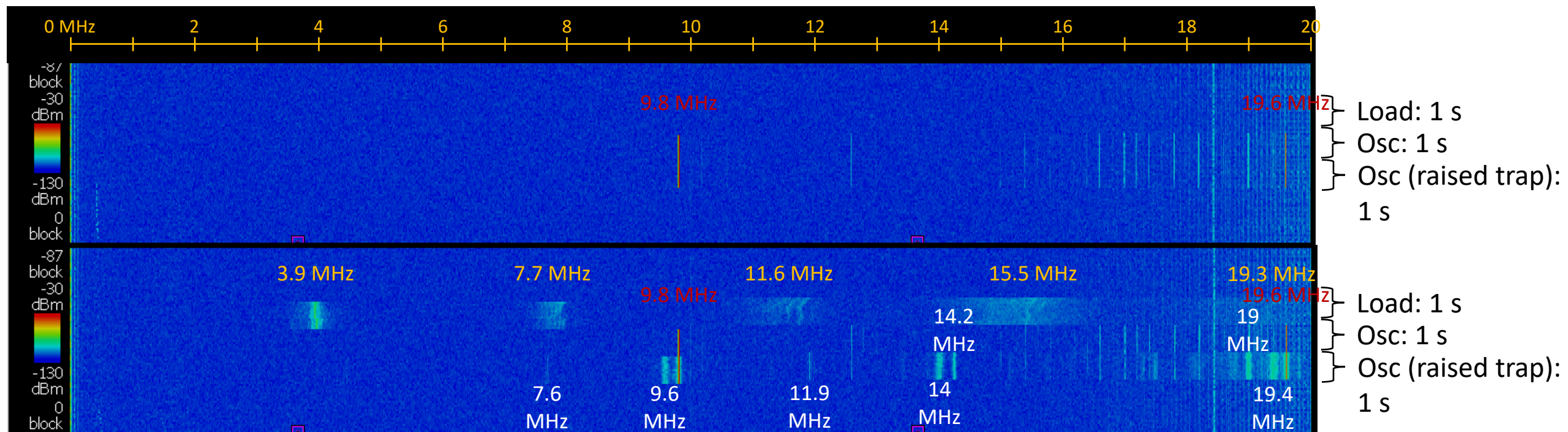
Plasma mode



Plasma mode



Background measurement: E-gun off



Conclusions



3. Examine the plasma mode.

The plasma mode results indicate the presence of multiple modes, requiring further investigation to understand what these modes are.

Conclusions and Outlook

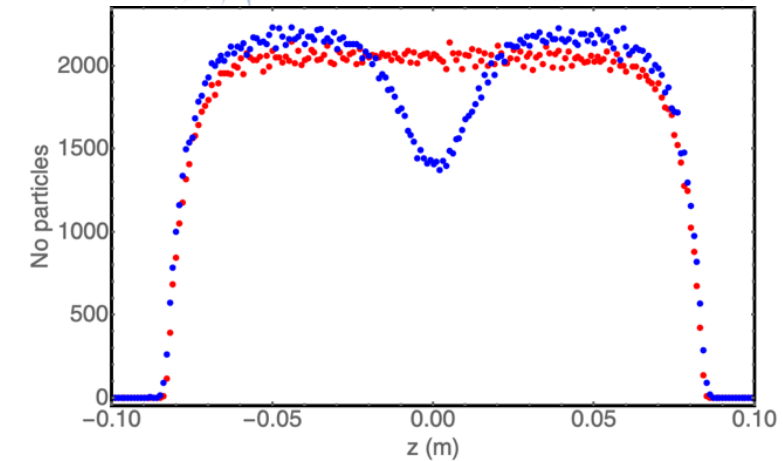
To generate a stable and high-density plasma, two key components are required:

1. Oscillating electric field
2. Dimple that traps ions

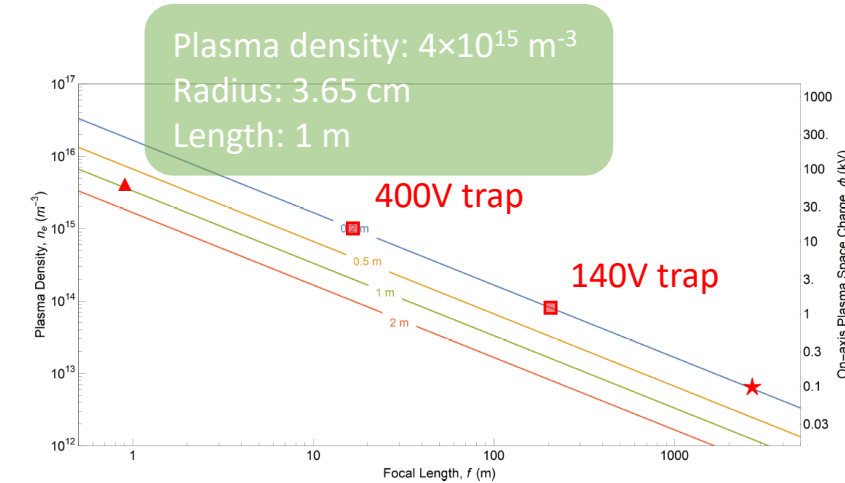
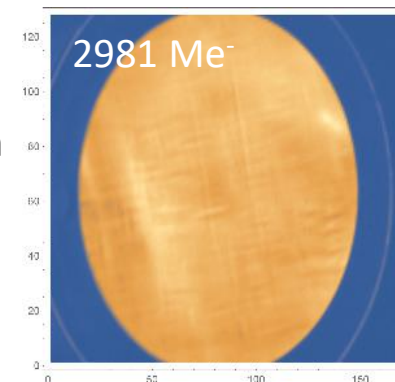
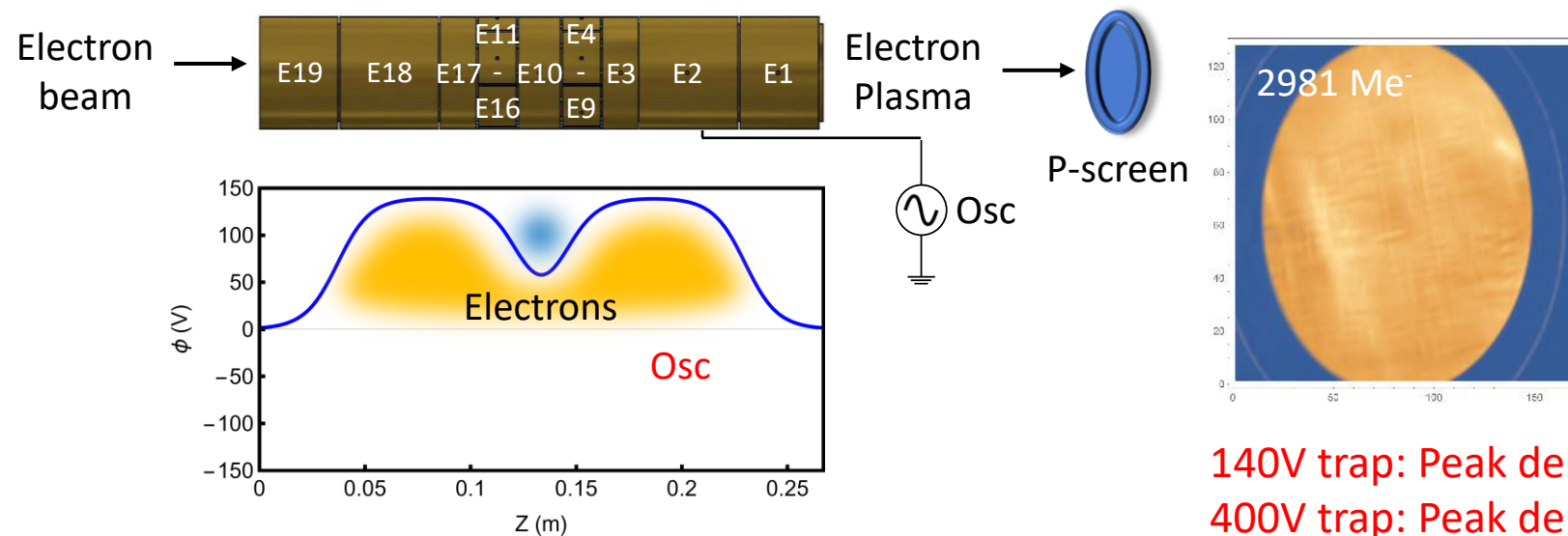
Notably, this plasma can be initiated using a very small number of seed electrons.

Next steps ...

- Further investigation on plasma modes.
- Conduct the experiments using Ar instead of CO₂.
- Use numerical simulation to verify our diagnostics.



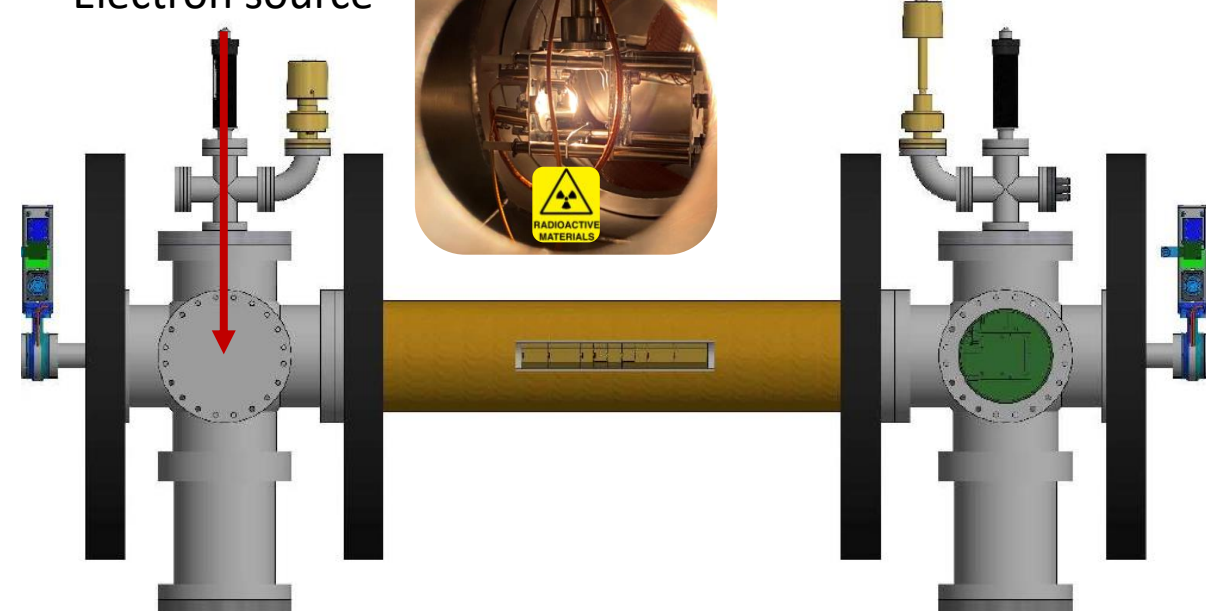
Simulated data by D. P. van der Werf



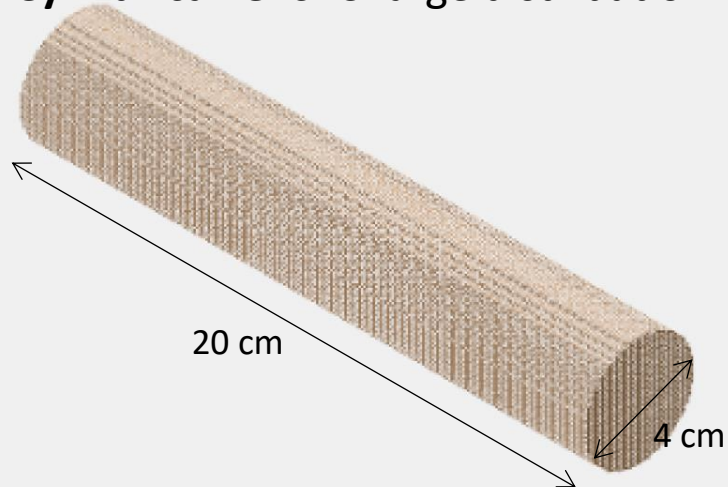
140V trap: Peak density $\approx 8 \times 10^{13} \text{ m}^{-3}$
 400V trap: Peak density $\approx 1 \times 10^{15} \text{ m}^{-3}$

Conclusions and Outlook

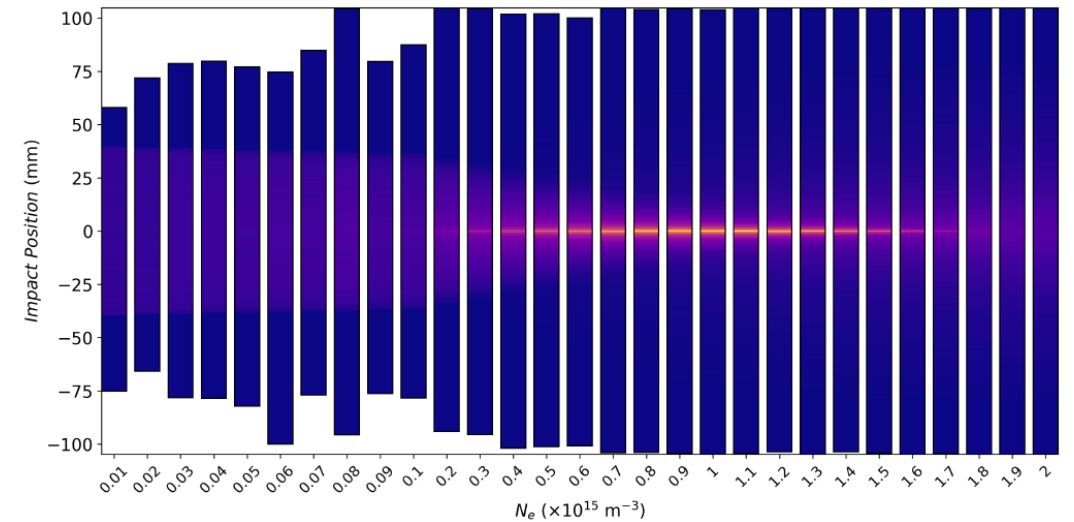
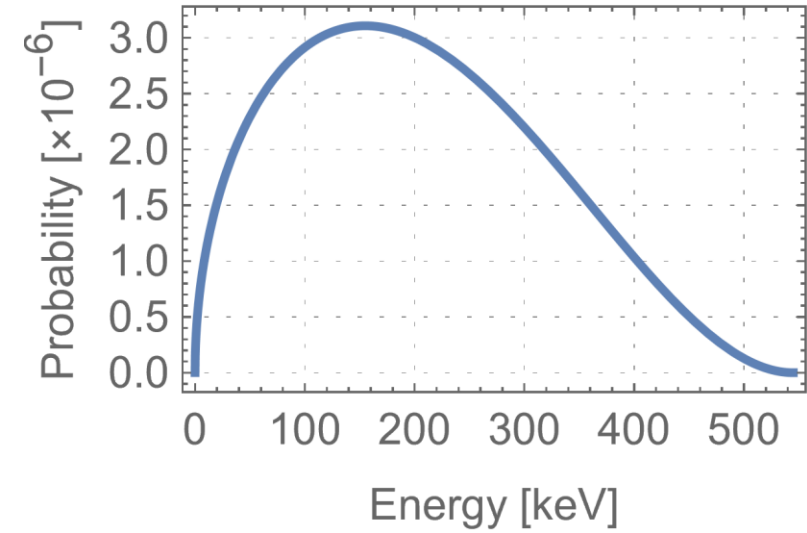
Electron source



Cylindrical lens: Charge distribution



Energy distribution of positrons emitted from the source (^{22}Na)



Plasma lens group



P. Ruksasakchai
W. Bertsche
M. Charlton
S. Eriksson
C. A. Isaac
D. P. van der Werf

